






System	Application	Replacement with	Touchscreen-Type
NV 6200 	Ion Implating System	$\lambda 19$ (E/V)	IR
 Endura/Centura/P5000 Mouse Control Touchcontrol	Ion Implating System	Lambda Konverter	—
		Lambda 19 LF (En)	Resistiv
Varian eHP220 / 500 	Ion Implating System	$\lambda 19$ (E/V)	IR
VIISion 80 / VIISion 200 	Ion Implating System	$\lambda 19$ (VII)	SAW
 E2000 E3200	It's a single-wafer epitaxial processing tool.	Lambda 19 LF (A) Lambda 19 LF RM (A)	Resistiv
		Lambda 17 VF (A3200)	Resistiv
Sigma Systems 	It's a single wafer cluster tool designed for high-volume Physical Vapor Deposition (PVD) processing.	$\lambda 15$ (T)	SAW

